

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****RECEIVED  
CENTRAL FAX CENTER****JUL 30 2007**

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR AND METHOD OF CONTINUOUS HTS TAPE  
BUFFER LAYER DEPOSITION USING LARGE SCALE ION BEAM  
ASSISTED DEPOSITION

App. No.: 10/609,250

Filed: June 26, 2003

Examiner: Ram N. Kackar

Group Art Unit: 1763

Customer No.: 34456

Confirmation No.: 7760

Atty. Dkt. No.: 1014-SP101-US

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MS RCE

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

**AMENDMENT IN SUPPORT OF RCE**

Dear Sir:

In response to the Final Office Action mailed March 28, 2007, please amend the  
above-identified application as follows: